

# Speckle Spectroscopy - X-ray Photon Correlation Spectroscopy

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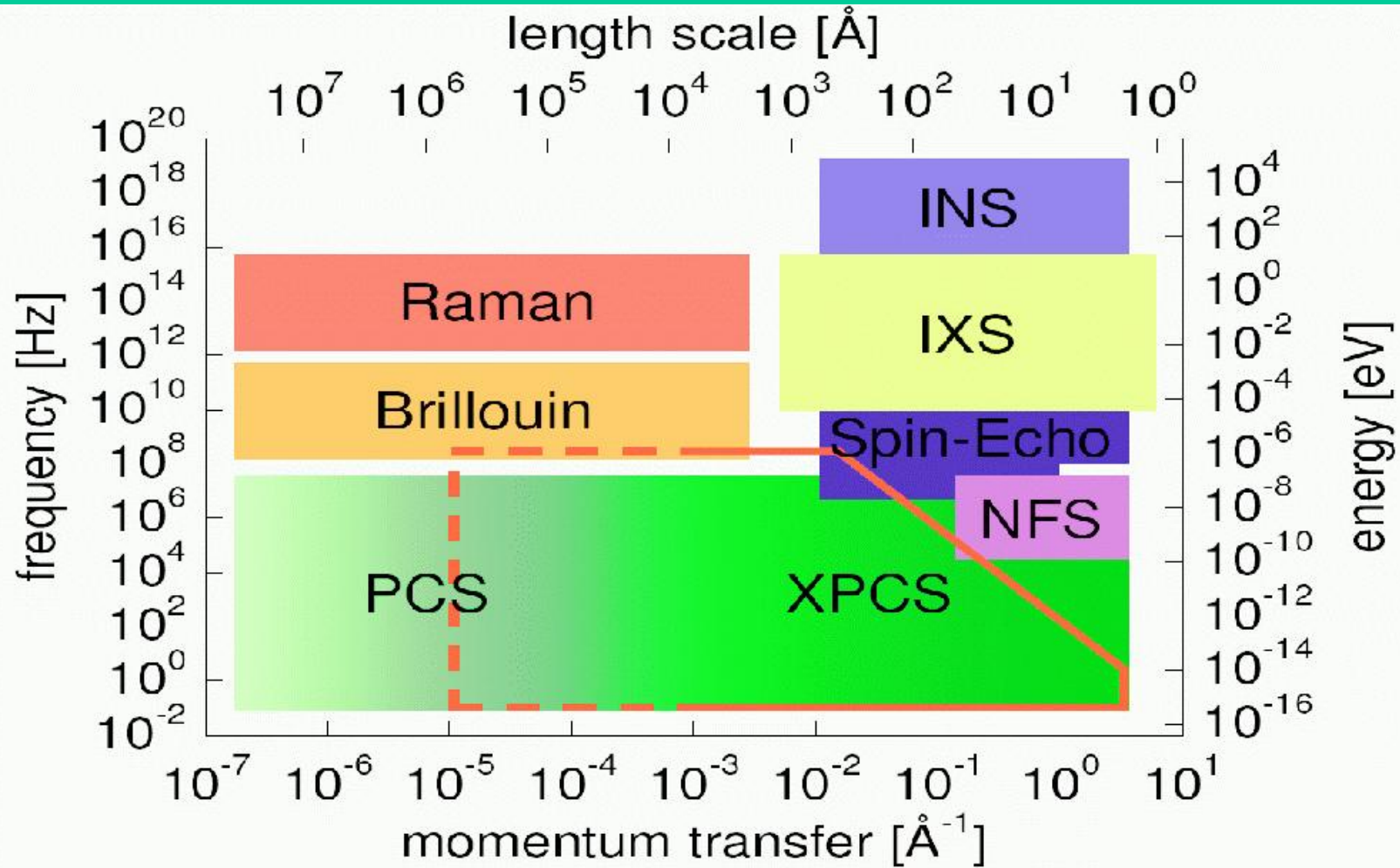
# Layout

- Introduction to coherent scattering
- Dynamics in different time scales
- Coherent Imaging
- Detectors - state of the art and future concepts
- Summary

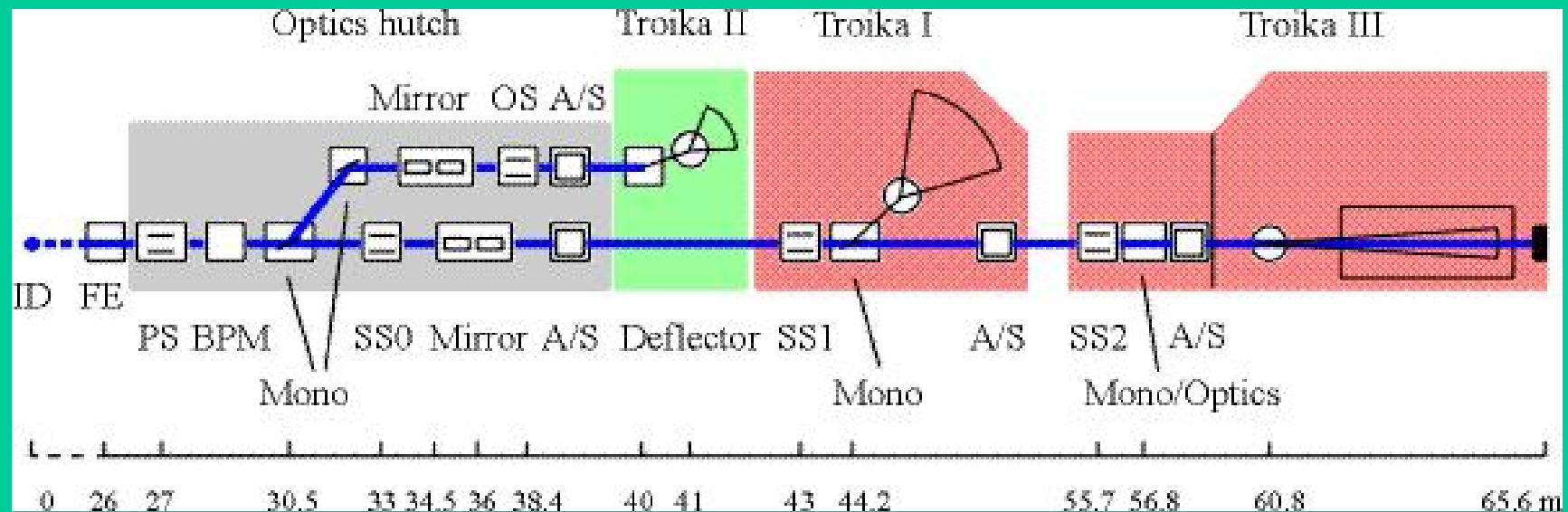
# XPCS - Overview

- XPCS is a scattering technique probing dynamics on nanoscaled systems
- XPCS uses coherent synchrotron radiation
- High degree of coherence only in a small beam cross section defined by an aperture  $\sim 10 \mu\text{m}$
- It involves small angle X-ray scattering (SAXS)
- 2D detectors with high spatial resolution  $\sim 20 \dots 200 \mu\text{m}$
- Scanning 0D detectors; Q-resolution by slit/pinhole

# XPCS - Overview



# ESRF ID10 - Overview



## Coherence lengths:

$$\xi_{\text{trans}} = \lambda/2 * R/s \sim 10 \dots 100 \mu\text{m}$$

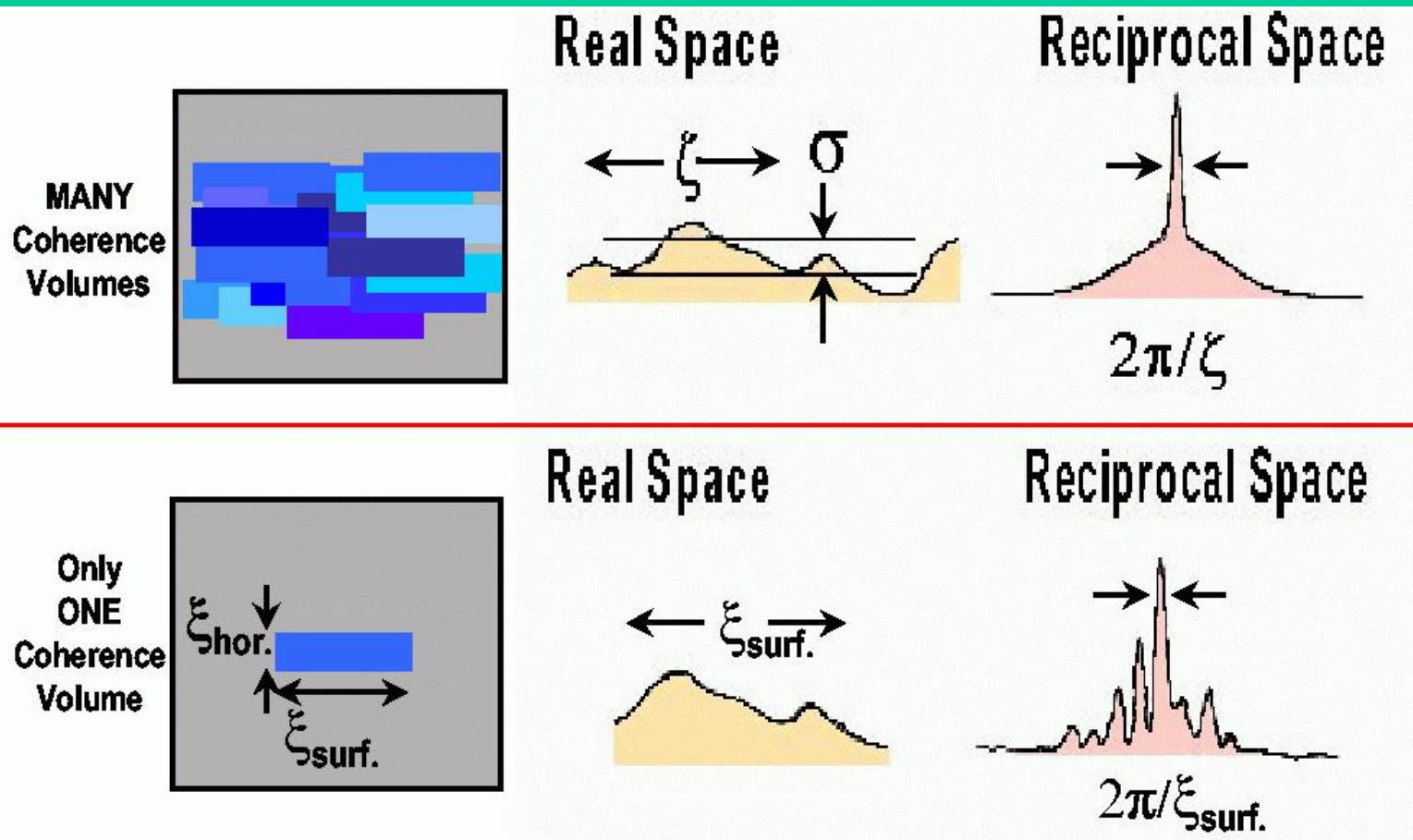
$$\xi_{\text{long}} = \lambda * (\lambda / \Delta\lambda) \sim 10 \text{nm} \dots 10 \mu\text{m}$$

## Coherent flux:

$$F_c = (\lambda/2)^2 * B$$

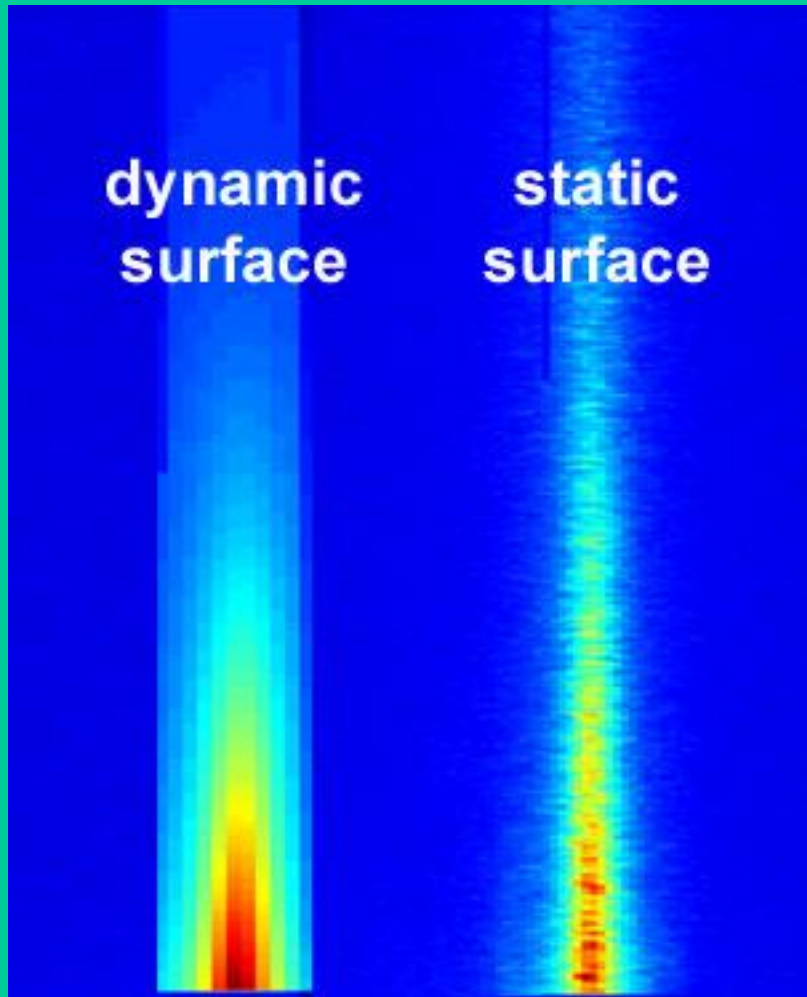
$$\text{ID10: } \sim 10^{10} \dots 10^{12} \text{ Hz}$$

# Coherent Scattering



From Metin Tolan

# Coherent Scattering



Polymer melt close to the glass transition

Speckle!

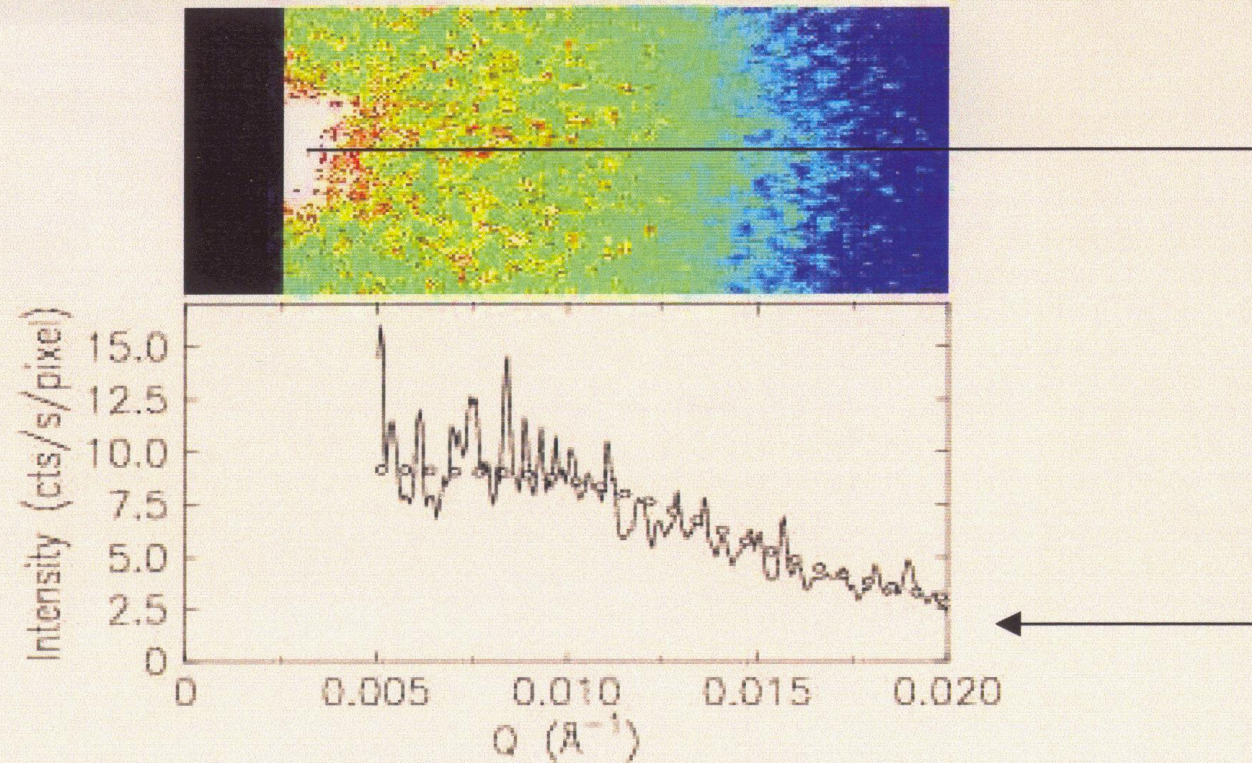
# Coherent Scattering

Aerogel

$\lambda=1\text{\AA}$

CCD

(22 $\mu\text{m}$  pixel)



Aerogel sample

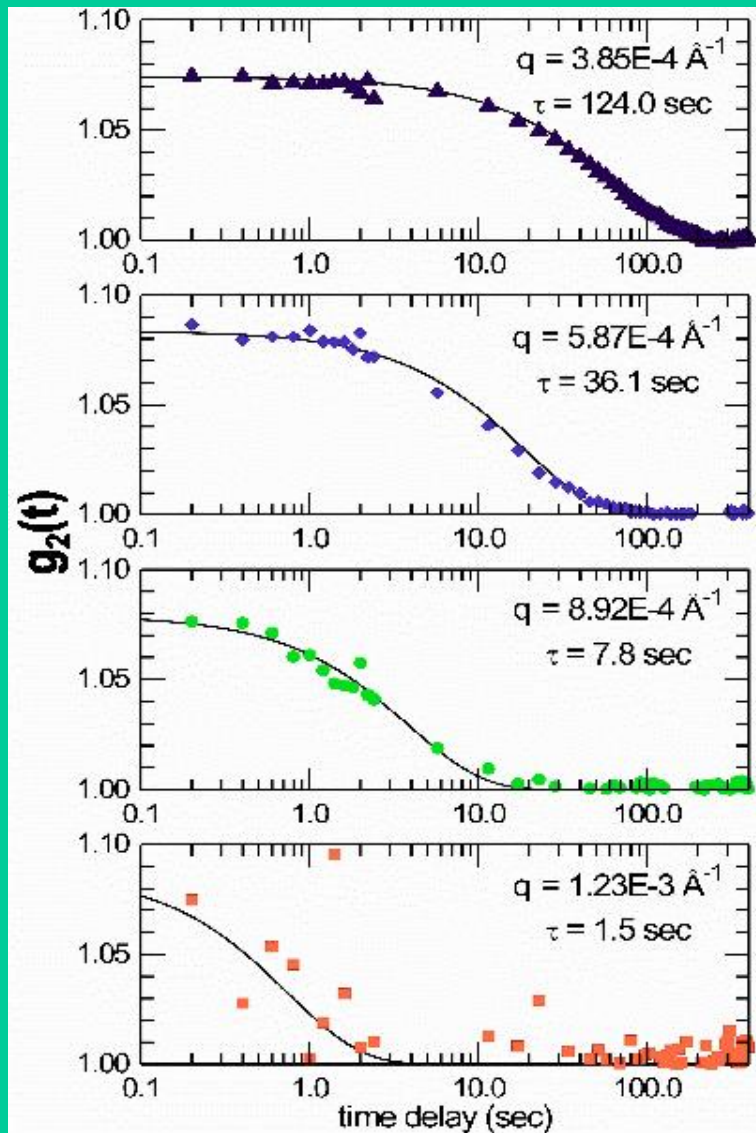
full line: coherent illumination

circles: incoherent illumination

D.Abernathy et al. JSR 5(1998), 37



# XPCS - slow dynamics



Polystyrene film on Si  
measured in reflection geometry

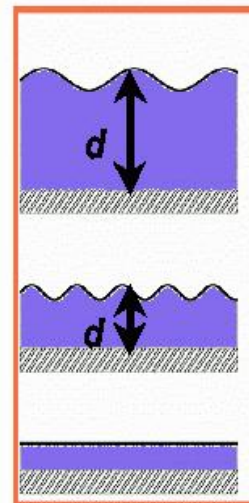
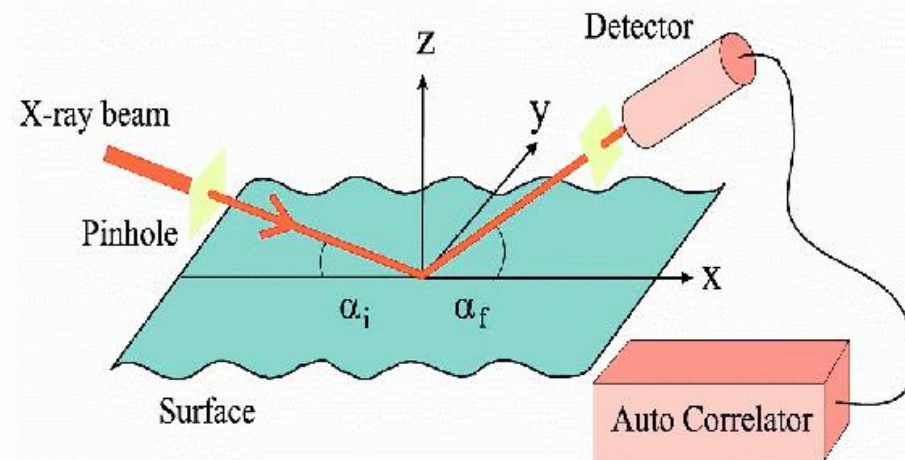
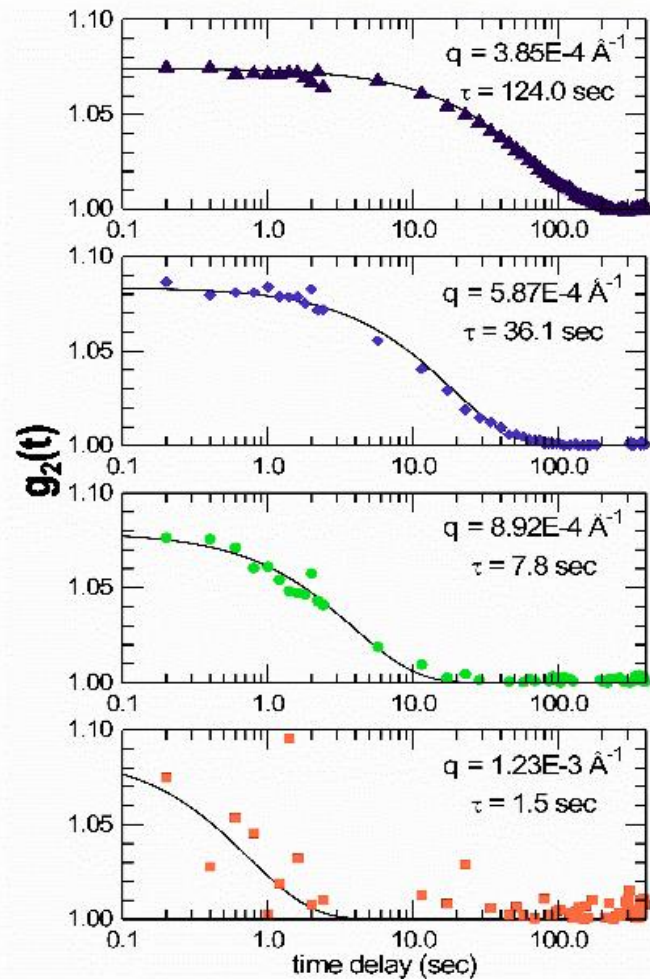
Autocorrelation function:

$$g_2(t) = \frac{\langle I(q, t') I(q, t' + t) \rangle}{\langle I(q, t') \rangle^2}$$

yields relaxation time

Kim et al. PRL 90(2003),068302

# XPCS - slow dynamics



## APS 8-ID: Dynamics of thin film polymer surfaces

Hyunjung Kim, A. Rühm, L.B. Lurio, J.K. Basu,  
J. Lal, D. Lumma, S.G.J. Mochrie, S.K. Sinha;  
*Phys. Rev. Lett.* **90**, 068302 (2003).

From Metin Tolan

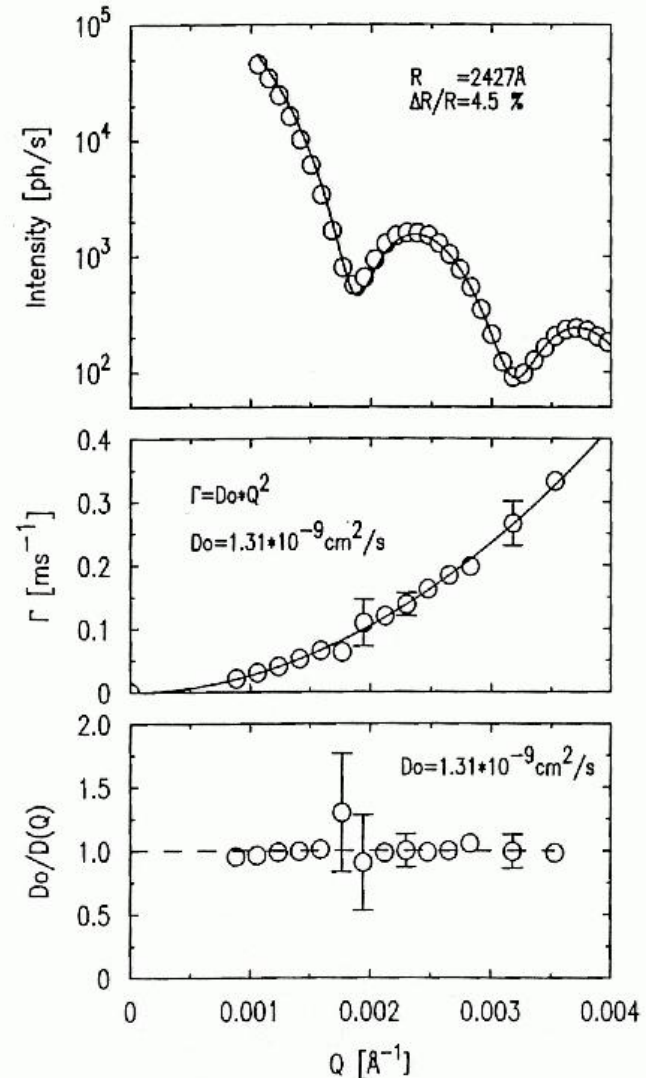
# XPCS - slow dynamics

SAXS pattern of 500nm colloidal silica in water/glycerol mixture

Relaxation rate determined from intensity correlation functions at various Q

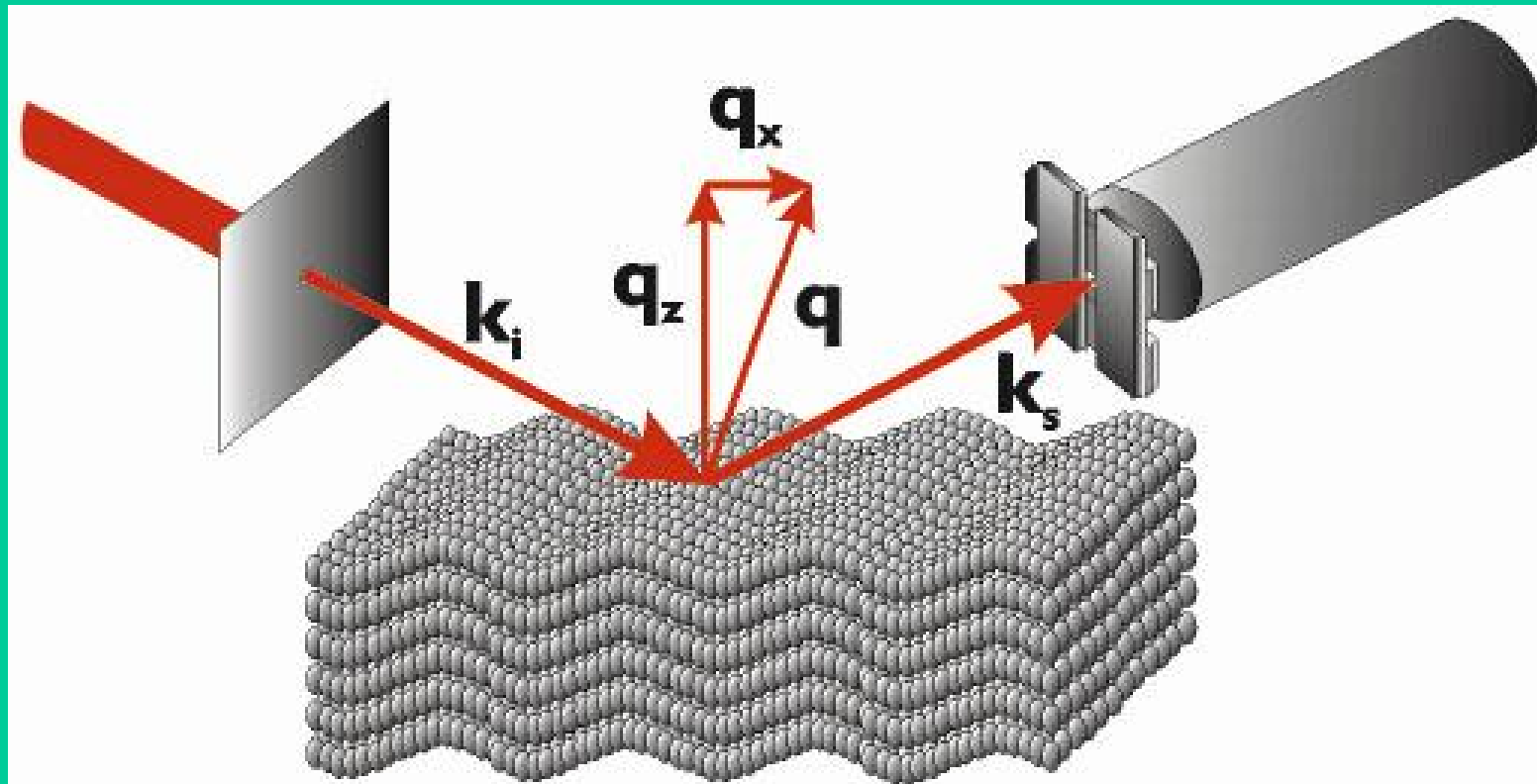
$D_0/D(Q)$  is Q independent  
no interaction of particles

G.Grübel et al. (1999) in *Slow Dynamics in Complex Systems*



# XPCS - slow dynamics

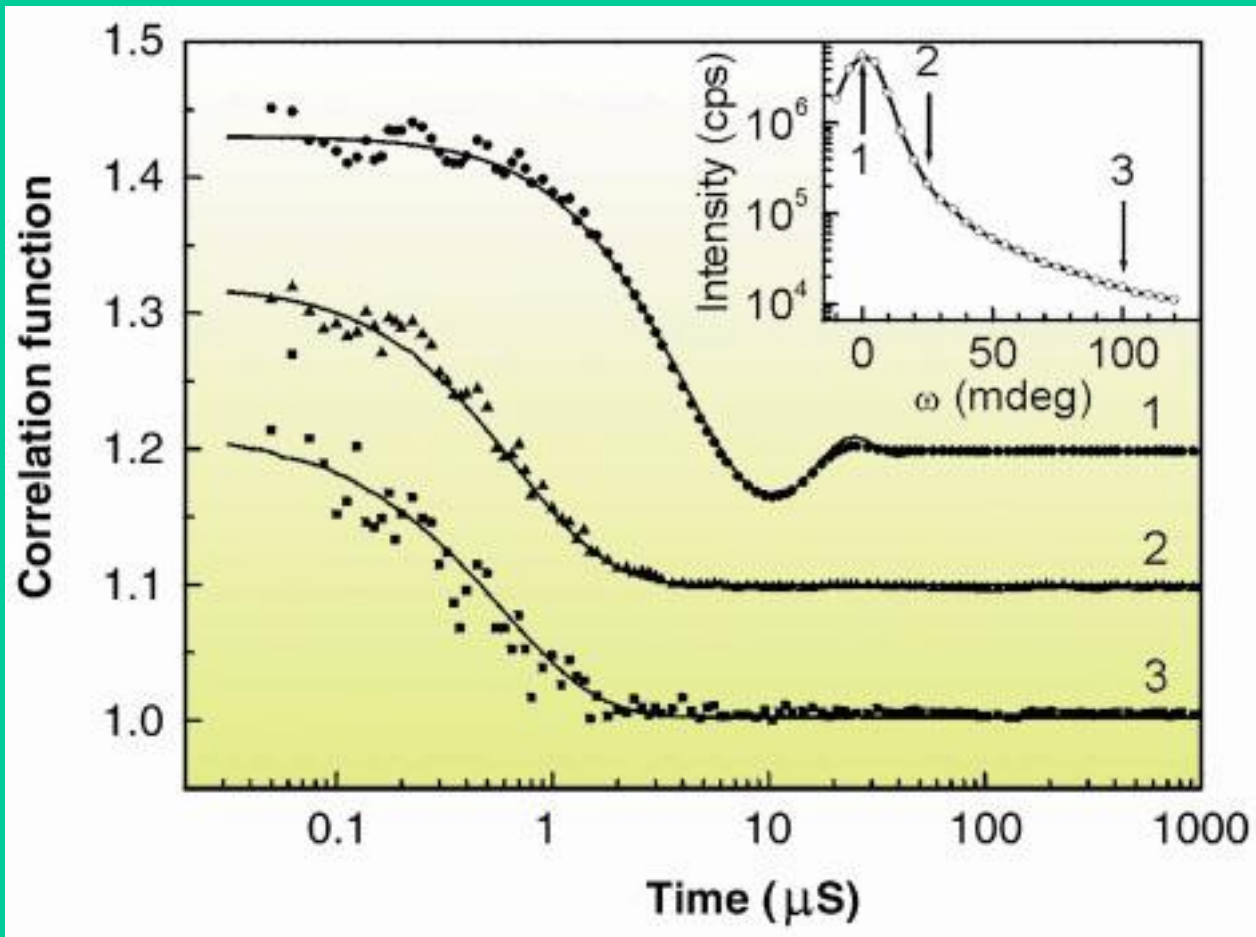
## Membranes in Motion



A.Fera et al. , ESRF Highlights 2001

# XPCS - slow dynamics

## Membranes in Motion



A.Fera et al. , ESRF Highlights 2001

# Summary on XPCS

Time correlation functions are determined  
either

by measuring continuously frames with 2D detector and  
software processing: characteristic times  $> 1\text{ s}$

or

by point detectors (APDs) and hardware autocorrelators  
till  $\mu\text{s}$

# Coherent Imaging and Reconstruction

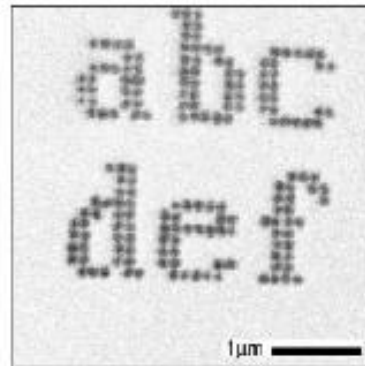


Figure 1 A scanning electron microscope image of the specimen. This specimen was fabricated by depositing gold dots, each  $\sim 100$  nm in diameter and 80 nm thick, on a silicon nitride membrane.

**letters to nature**

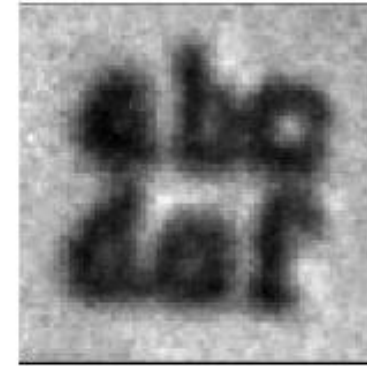


Figure 3 An optical microscope image of the specimen.

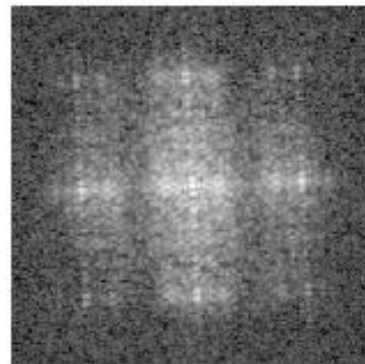


Figure 2 A diffraction pattern of the specimen (using a logarithmic intensity scale). The central 15 pixel rectangular area is replaced by the squared magnitude of the Fourier transform of the optical microscope image (Fig. 3)

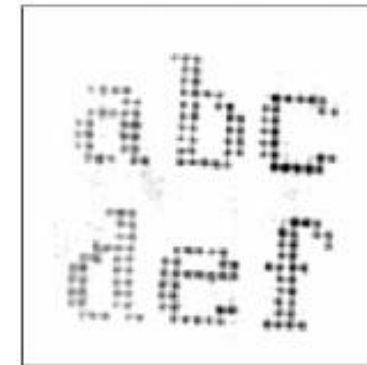


Figure 4 The specimen image as reconstructed from the diffraction pattern of Fig. 2.

J. Miao et al., Nature 400(1999), 342

# Coherent Imaging and Reconstruction

## Oversampling technique

Spatial frequency on the detector has to be at least twice as large as the smallest scattering feature

Reconstruction is performed in an iterative way starting from random phases

Uses a „support“, which should be defined by the sample size



# Coherent Imaging and Reconstruction

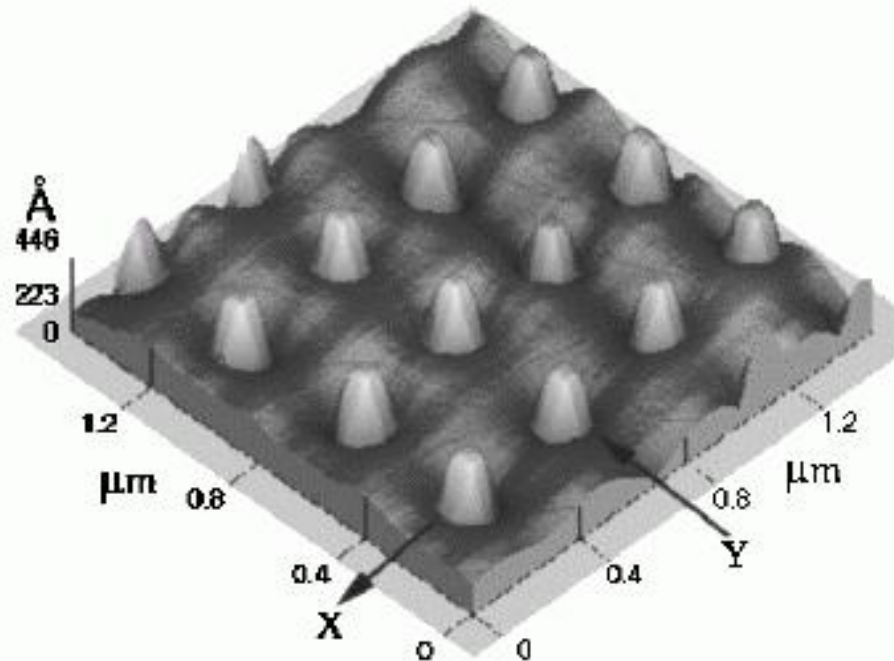
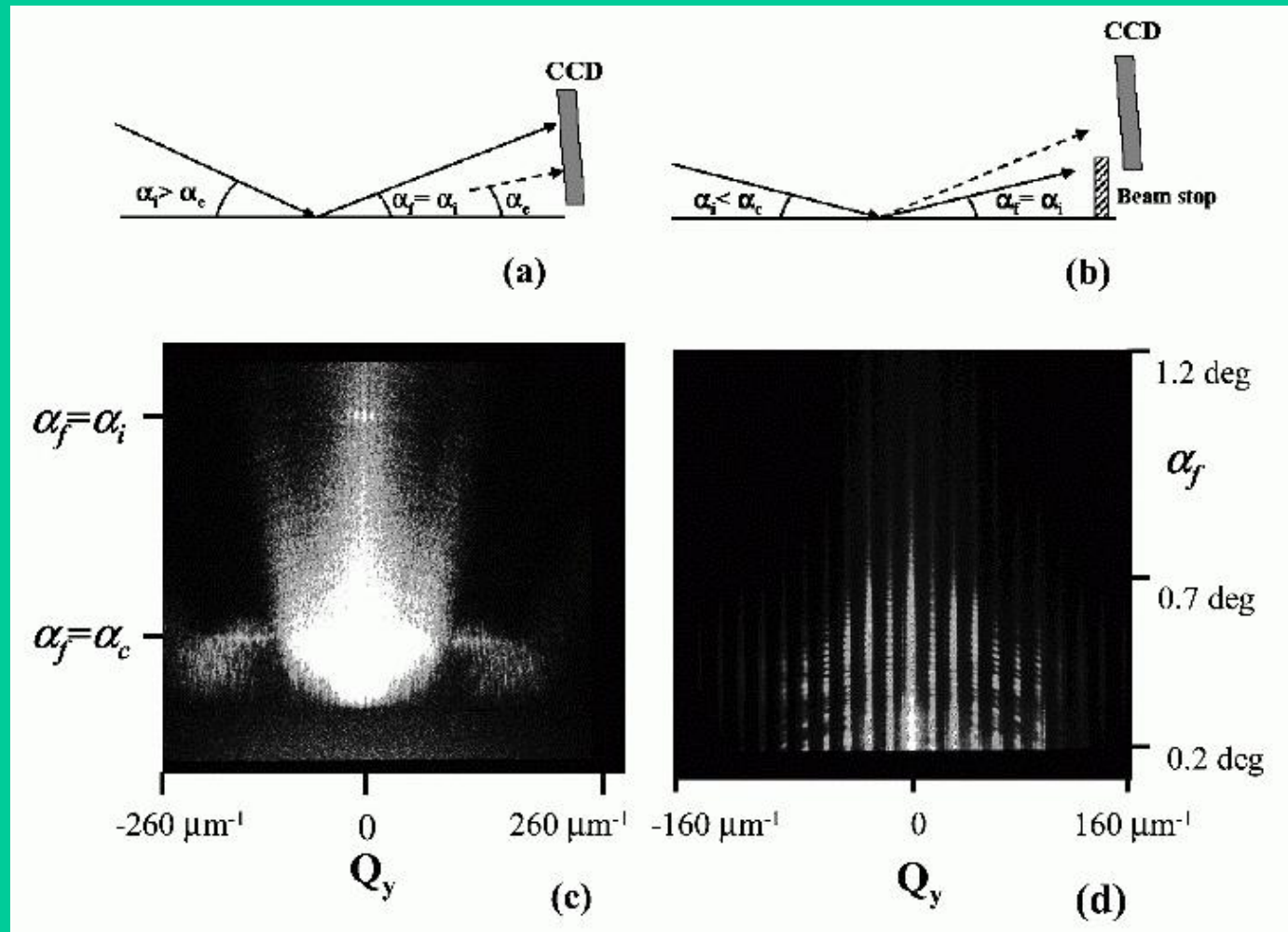


FIG. 1. AFM micrographs of 2D ordered Ge islands.

Ge Quantum Dots on Si

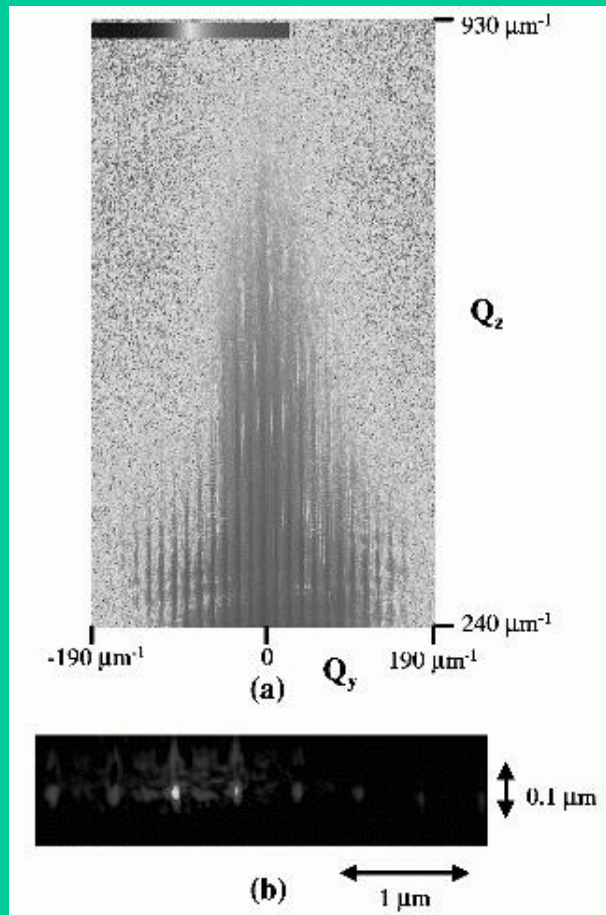
I. Vartanyants et al. PRB 71(2005), 245302

# Coherent Imaging and Reconstruction



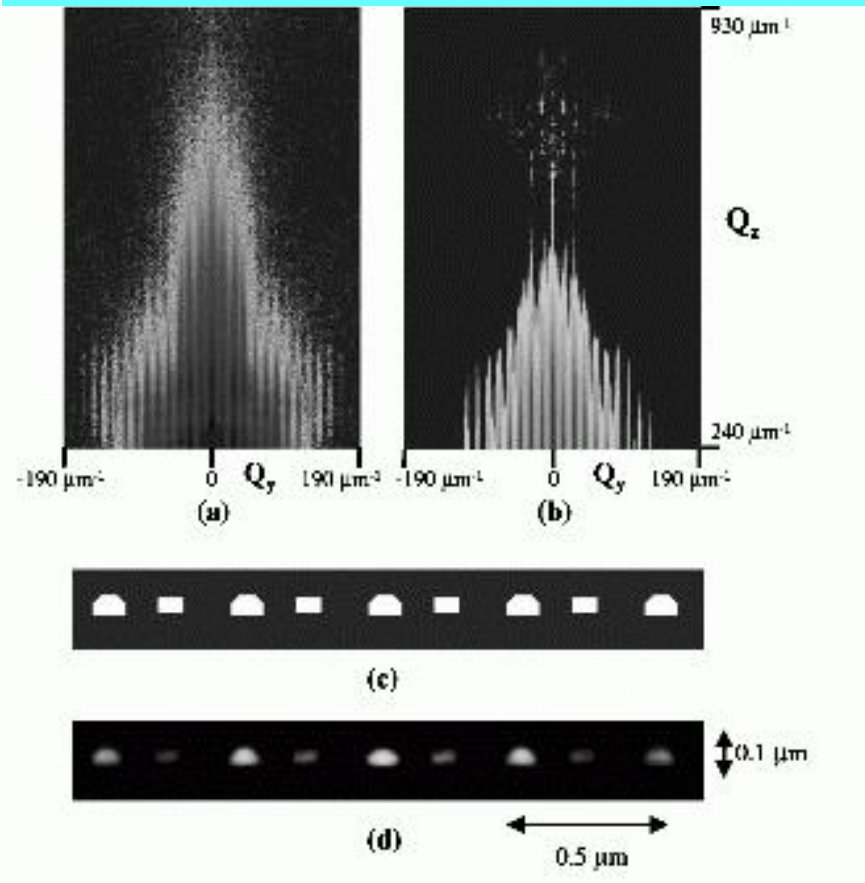
I. Vartanyants et al. PRB 71(2005), 245302

# Coherent Imaging and Reconstruction



Top: reconstructed SAXS pattern  
bottom: support + reconstruction

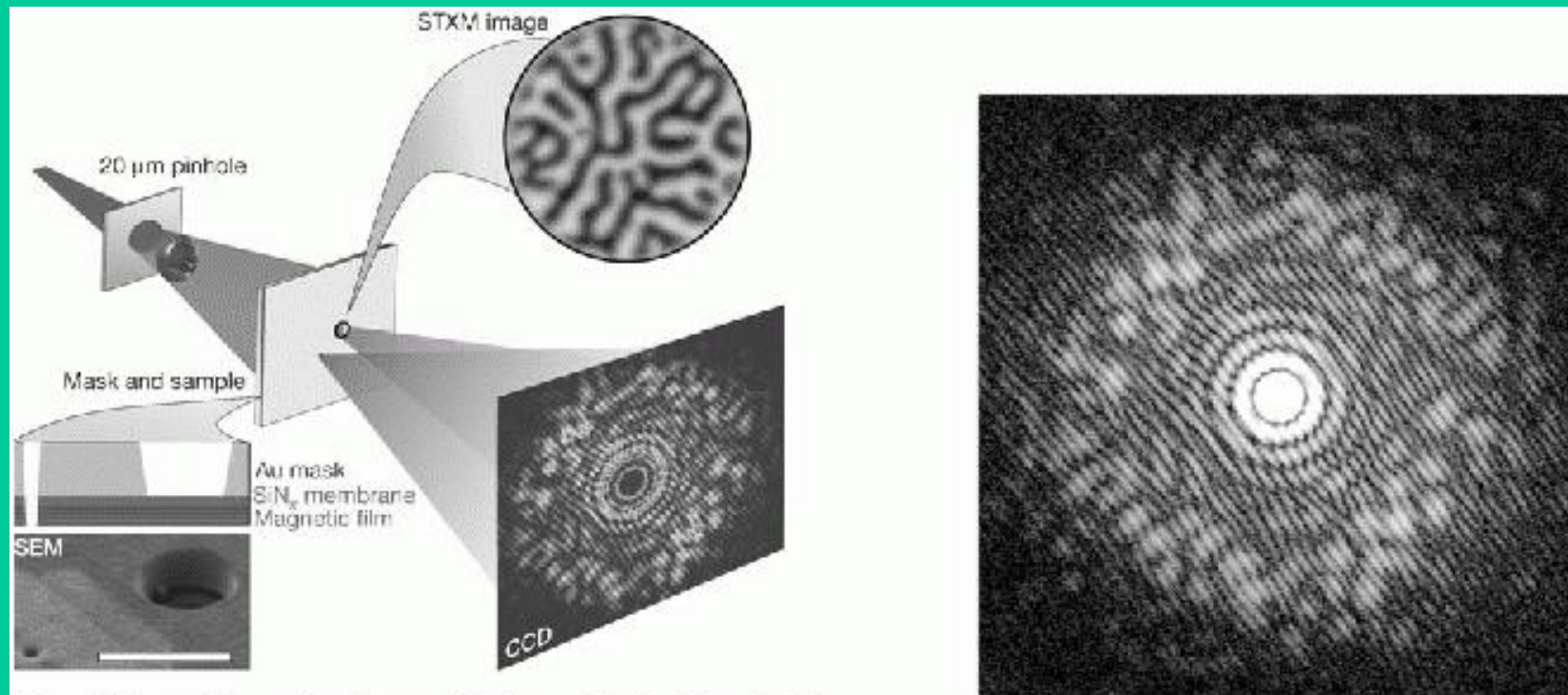
exp. data      reconstructed data



c: refined support  
d: reconstruction

# Coherent Imaging and Reconstruction

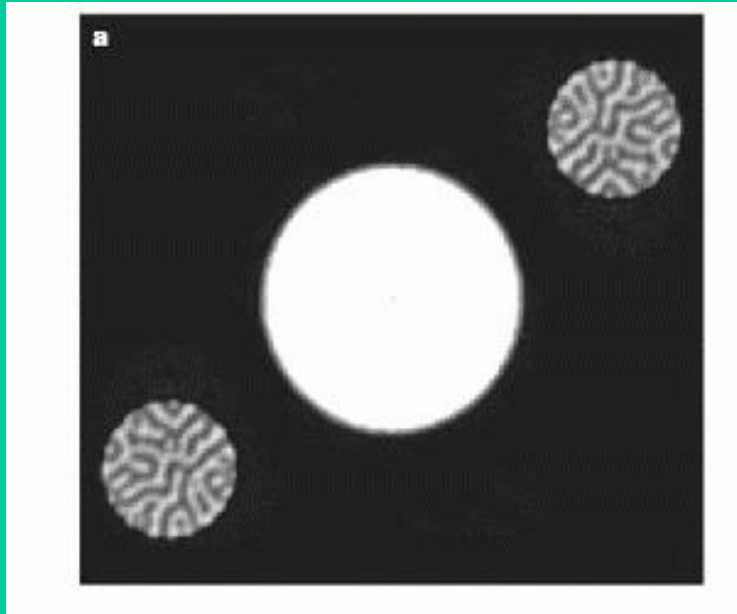
Magnetic lensless imaging on Co/Pt-ML (Co L-edge) at Bessy using circularly polarized synchrotron radiation



**Figure 1** Scheme of the experimental set-up. Monochromatized and circular polarized

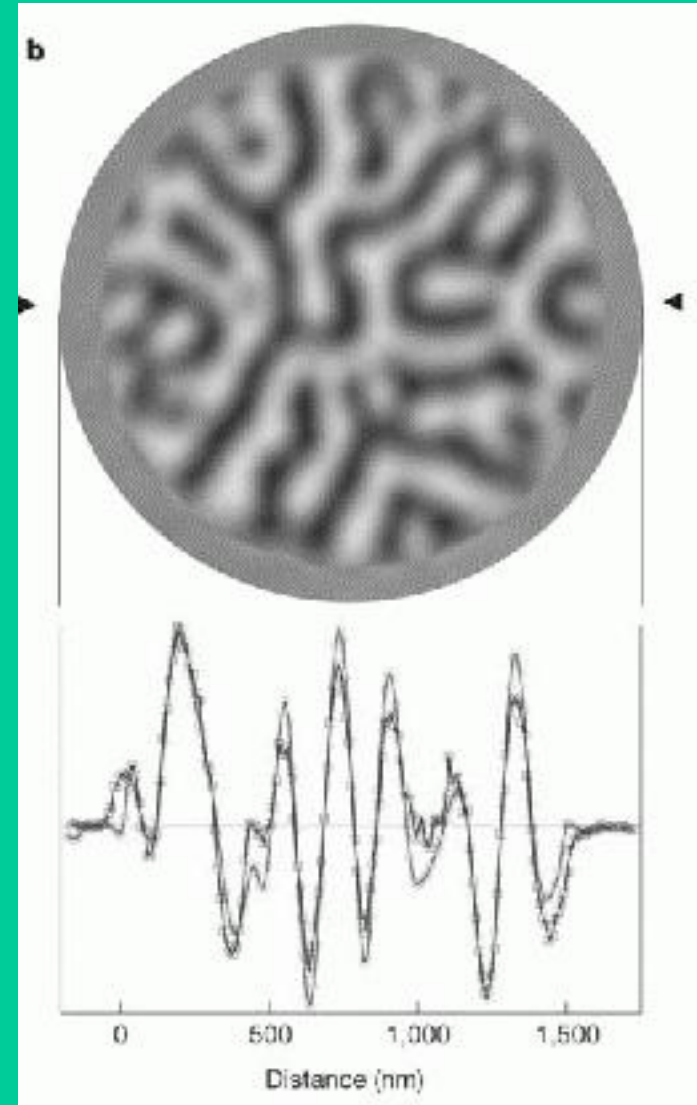
S. Eisebitt et al., Nature 432(2004), 885

# Coherent Imaging and Reconstruction



FT of the hologram

Reconstruction and comparison with STXM



# Summary on Imaging

Imaging always uses 2D detectors

Requirements on resolution:

small pixel size necessary to „see“ the whole sample

large number of pixels (large total size) to resolve small structures at high Q

Reconstruction by Oversampling (iterative technique)

Direct reconstruction after holographic recording;

lensless imaging of magnetic nanostructures

# Avalanche Photo Diodes

## Commercial Suppliers for APDs and Developers

APDs are manufactured by

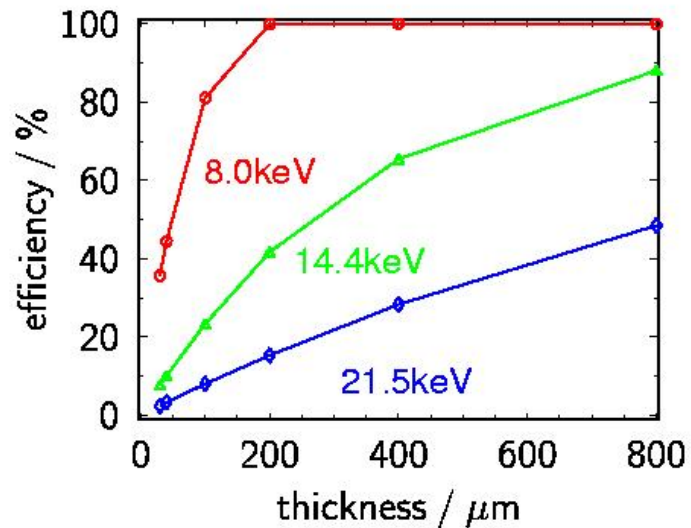
- Advanced Photonix (USA)
- Hamamatsu (Japan)
- Perkin Elmer Optoelectronics – former EG & G (Canada)
- Radiation Monitoring Devices – RMD (USA)

APDs were introduced in SR research by

- S. Kishimoto – Inst. of Materials Structure Science, Tsukuba
- A. Baron – SSRL, ESRF, Spring-8

# Avalanche Photo Diodes

## Ways to Increase Efficiency of APD Detectors



- 30 μm : Hamamatsu APD
- 40 μm : Advanced Photonix APD
- 100 μm : Perkin Elmer APD
- 200 μm : Perkin Elmer APD (inclined)
- 400 μm : 4 Perkin Elmer APDs stacked
- 800 μm : 4 Perkin Elmer APDs stacked and inclined

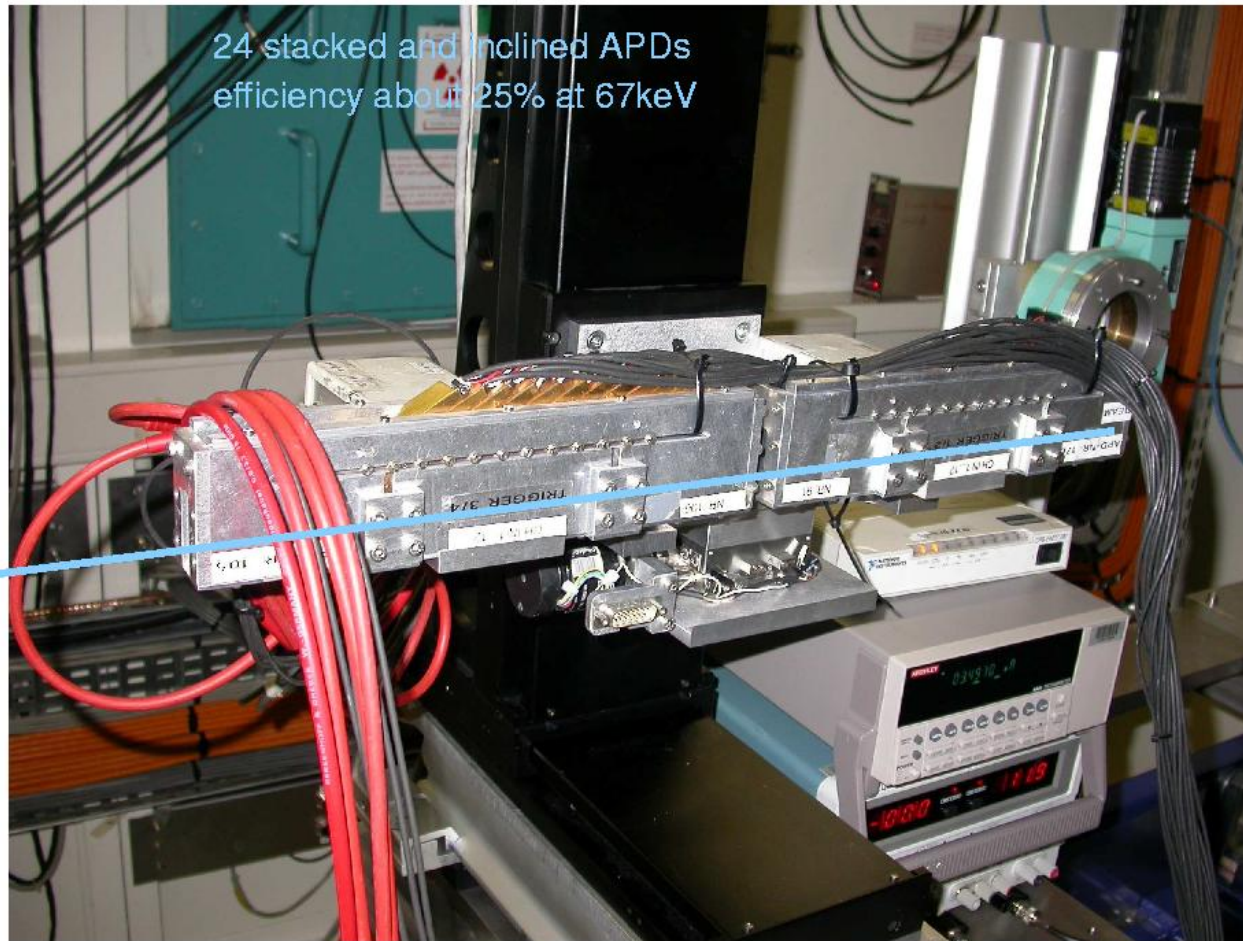
The last 4 are standard solutions at ID18 at the ESRF

This will be a problem with arrays!

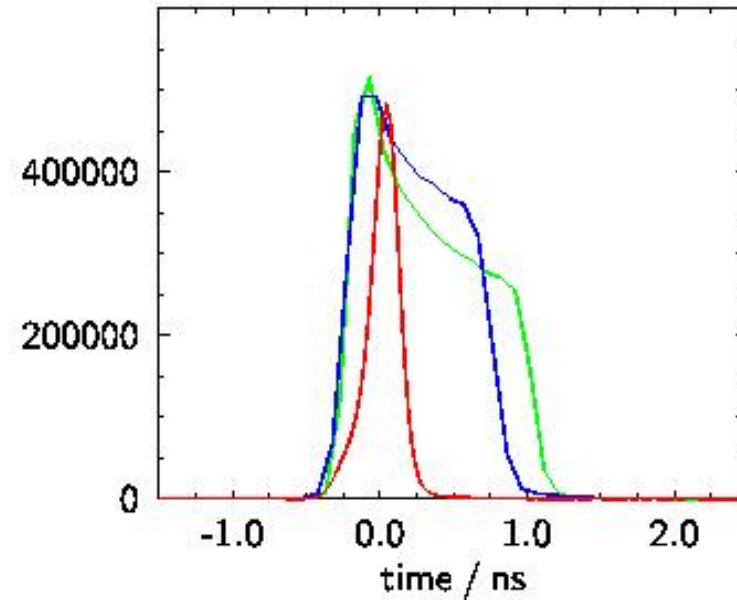
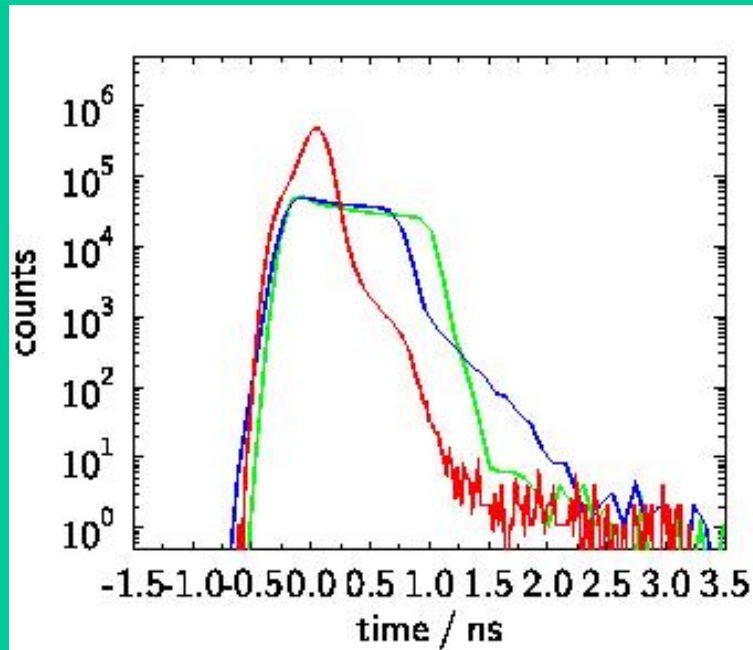


# Avalanche Photo Diodes

## Ways to Increase Efficiency of APD Detectors



# Avalanche Photo Diodes



EG & G 5mm

Hamamatsu 3mm

Hamamatsu 3mm perpendicular

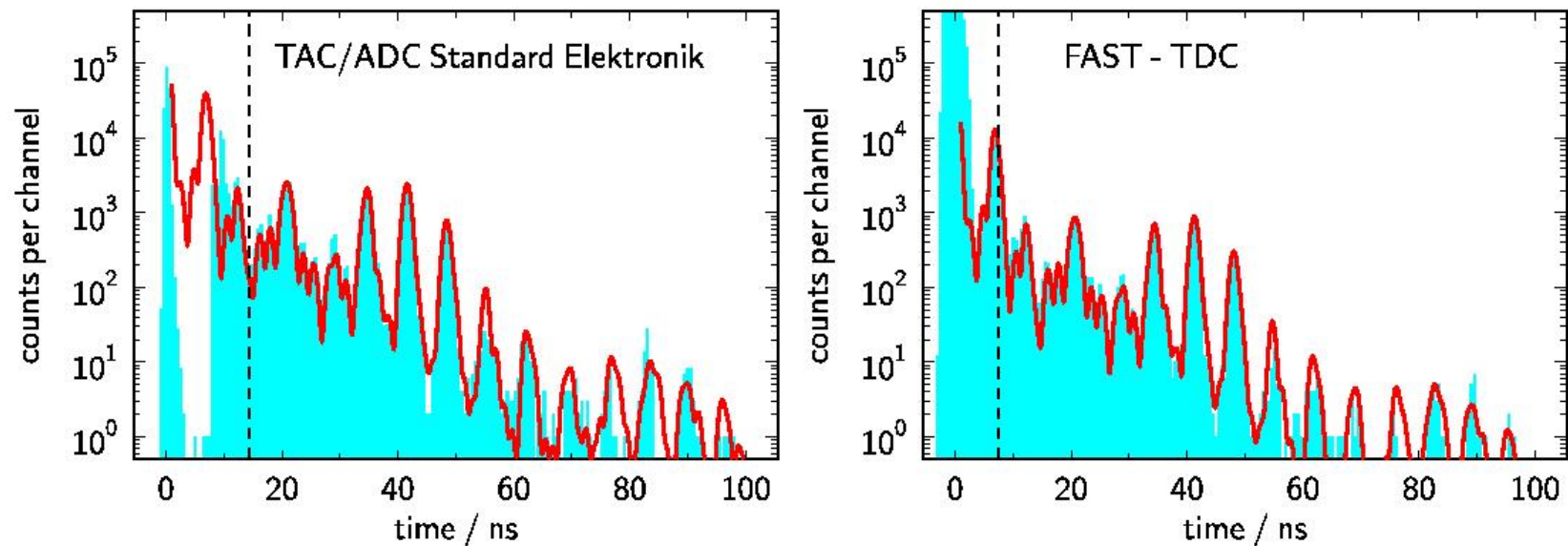
Focused beam *APD active layer*



# Avalanche Photo Diodes

EuS  $T=7\text{K}$   $H=0$

Nuclear Resonant Scattering time spectra – Perkin Elmer APD



Vertical dashed lines show begin of fit region

# Summary on point APDs

Manufacturer:

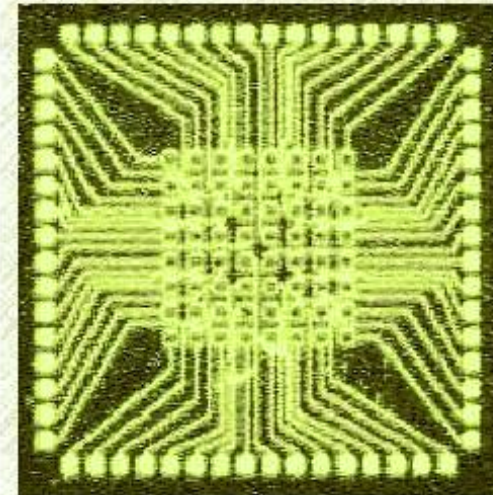
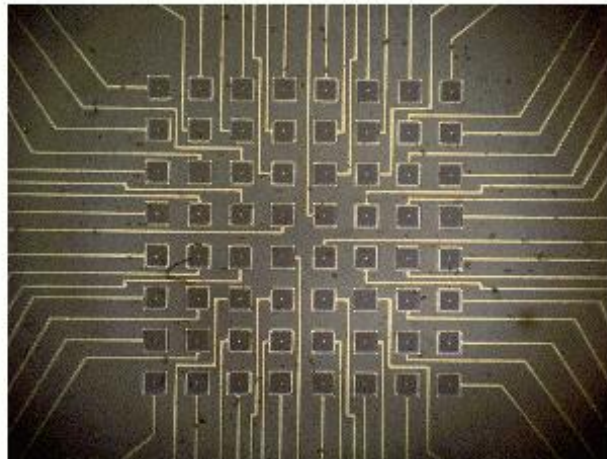
RMD, Advanced Photonix not recommended

Perkin Elmer, Hamamatsu very reliable

Perkin Elmer more efficient

Hamamatsu can be faster, especially in „perpendicular incidence“

# APD array



64-element APD array for imaging.  
Size of elements 100um\*100um

Fig. 1: Array of GMPD's. A microscopic view is shown left and the chip layout with pads right.

left: 8 x 8 array of APDs  
right: APD array and chip layout  
Disadvantage: only 3  $\mu\text{m}$  thick

# Important points for APD arrays

Electronics „downstream“ has to be developed!

Collaborations: Medipix? PSI? Cornell? MPI Munich? ...

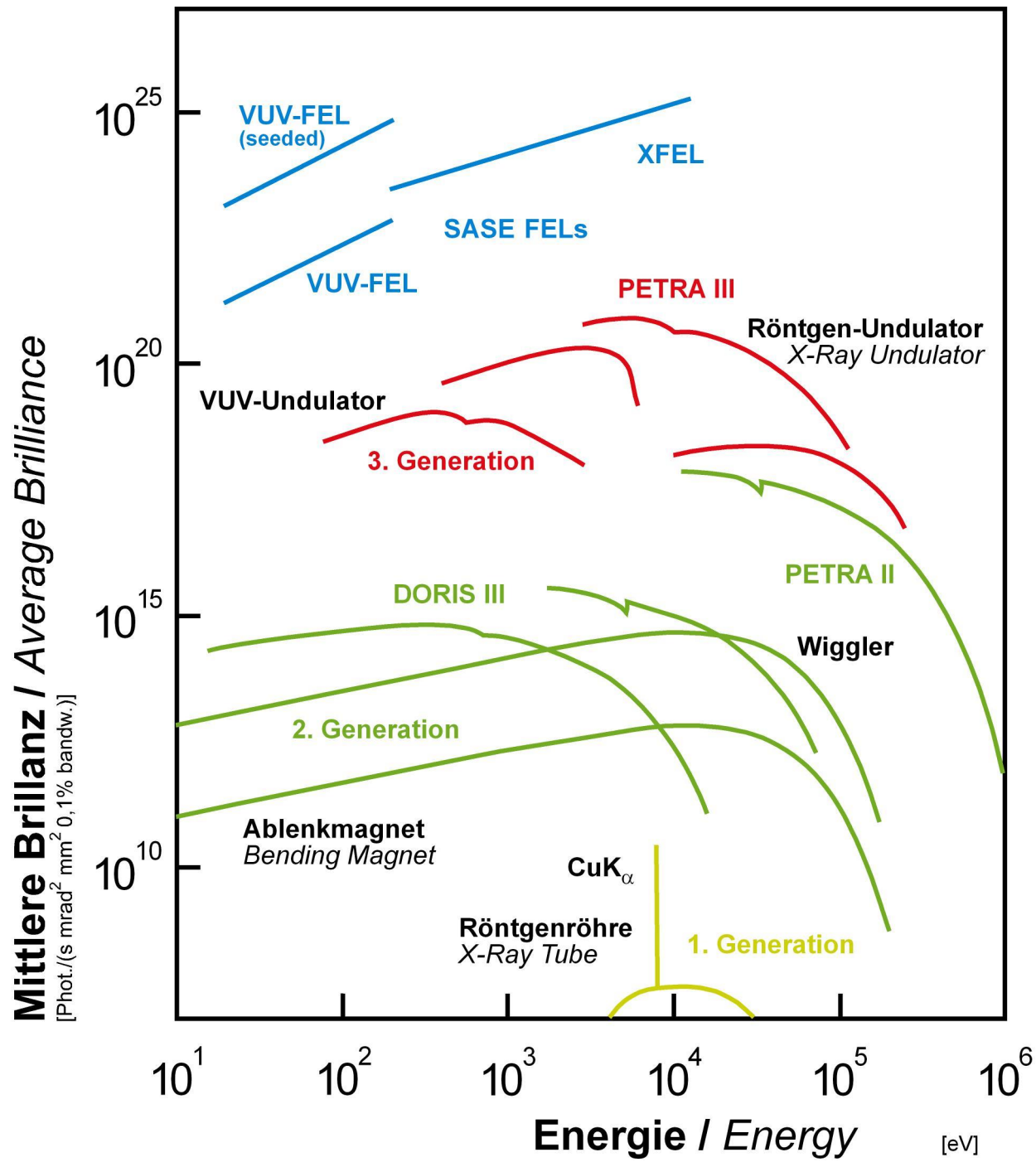
Autocorrelator hardware per pixel??

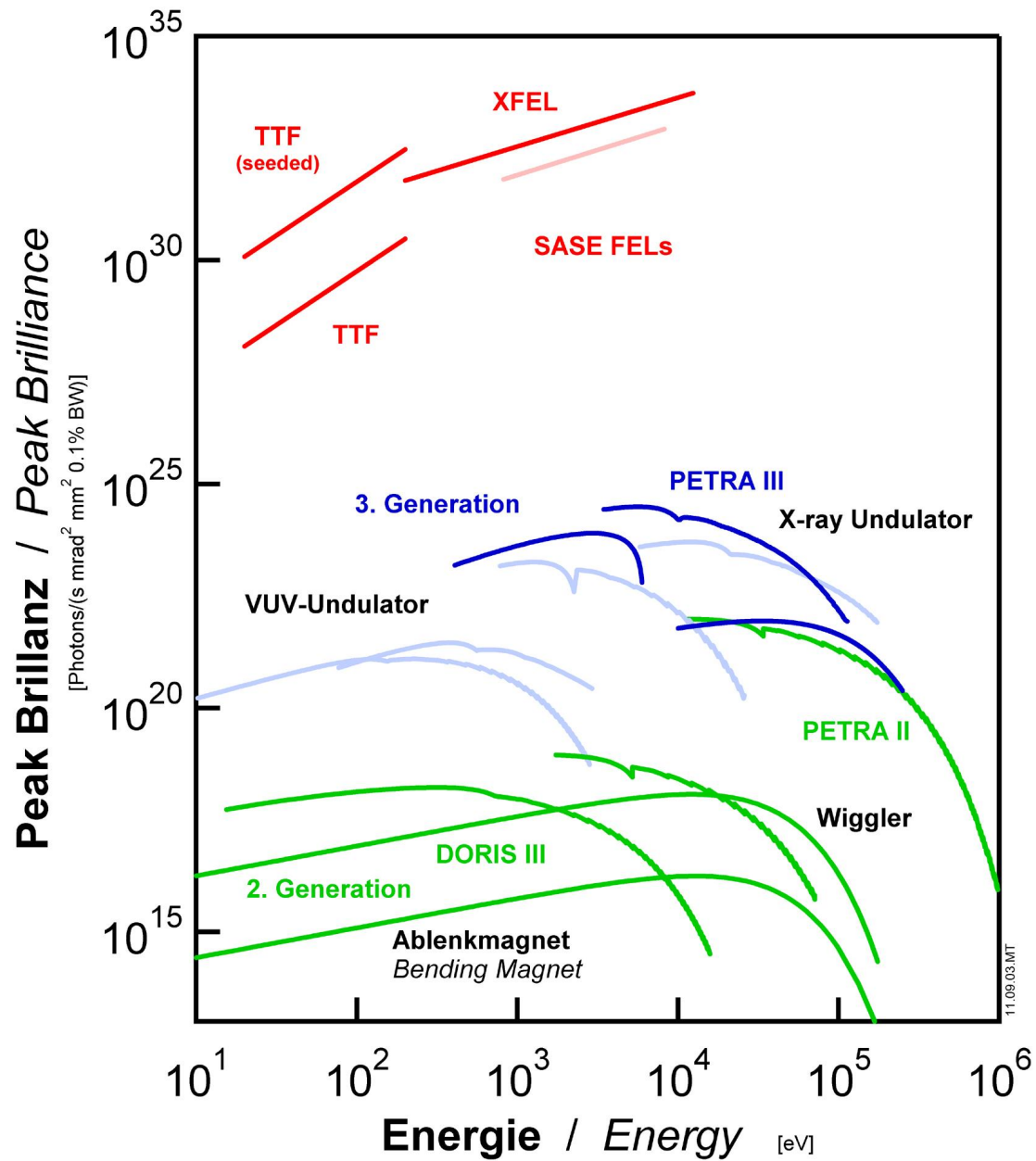
Fast read-out and software solution?? Much more flexible!

Single photon device or integrating device?

„simple“ register/counter or ADC

Future sources, especially X-FEL, many photons per bunch!







# Conclusions

- XPCS is a well established technique for slow dynamics
- Coherent Imaging and reconstruction (including magnetic imaging) increasing
- Detectors are bottleneck; there is a need for fast 2D-detector systems

# Acknowledgements

- G. Grübel, M. Lohmann, DESY Hamburg
- A. Robert, ESRF Grenoble
- M. Tolan, Univ. Dortmund
- A. Baron, Spring-8
- R. Rüffer, T. Deschaux





















